



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yee-Chung Fu
Assignee: Advanced Nano Systems, Inc.
Amended Title: MEMS Scanning Mirror with Trenched Surface and Tapered Comb Teeth for Reducing Inertia and Deformation
Serial No.: 10/779,952 Filing Date: February 13, 2004
Examiner: Allan R. Wilson Group Art Unit: 2815
Docket No.: ANS-P105

San Jose, California
July 19, 2005

Mail Stop Issue Fee
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT UNDER RULE 1.312(a)

Dear Sir:

Pursuant to 37 C.F.R. §1.312(a), please amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.